

(19) United States

(12) Patent Application Publication (10) Pub. No.: US 2024/0213199 A1

Jun. 27, 2024 (43) **Pub. Date:**

(54) SEMICONDUCTOR PACKAGE AND METHOD OF FABRICATING THE SAME

(71) Applicant: Samsung Electronics Co., Ltd.,

Suwon-si (KR)

Inventors: Sungwoo PARK, Suwon-si (KR);

Yongjae KIM, Suwon-si (KR); Heonwoo KIM, Suwon-si (KR); Seung-Kwan RYU, Suwon-si (KR)

Assignee: Samsung Electronics Co., Ltd.,

Suwon-si (KR)

Appl. No.: 18/227,646

(22)Filed: Jul. 28, 2023

(30)Foreign Application Priority Data

Dec. 23, 2022 (KR) 10-2022-0183175

Publication Classification

(51) Int. Cl.

H01L 23/00 (2006.01)H01L 23/498 (2006.01)H01L 25/065 (2006.01)

(52) U.S. Cl.

CPC H01L 24/13 (2013.01); H01L 23/49816 (2013.01); H01L 24/16 (2013.01); H01L 24/17 (2013.01); H01L 25/0657 (2013.01); H01L 2224/13017 (2013.01); H01L 2224/16225 (2013.01); H01L 2224/1703 (2013.01); H01L 2225/06517 (2013.01); H01L 2225/06544 (2013.01); H01L 2924/37001 (2013.01)

(57)ABSTRACT

The present disclosure provides semiconductor packages and methods of fabricating the same. In some embodiments, a semiconductor package includes a substrate including first and second regions, a first pad on the first region, a second pad on the second region, a first dielectric layer on the first region and including a first opening exposing the first pad, a second dielectric layer on the second region and including a second opening exposing the second pad, a first bump structure on the first pad and in the first opening, and a second bump structure on the second pad and in the second opening. A thickness of the first dielectric layer is greater than a thickness of the second dielectric layer. A distance between the substrate and an uppermost end of the first bump structure is longer than a distance between the substrate and an uppermost end of the second bump structure.

